



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Application of:

ONO, Toshiaki et al.

Group Art Unit: 1765

Serial No.: **09/883,922**

Examiner: **ANDERSON, M.**

Filed: **June 20, 2001**

P.T.O. Confirmation No.: **3735**

For: **METHOD OF MANUFACTURING EPITAXIAL WAFER AND METHOD OF PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: June 20, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated February 26, 2003 for one month from May 26, 2003 to June 26, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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